

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 2345/108	SERIAL NO. To be assigned
	APPLICANT Hans Wilfried Peter KOOPS 09/462283	
	FILING DATE Herewith	GROUP To be assigned 17A6

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
SA	196 16 324*	October 30, 1997	DE				
SA	0 614 126*	September 7, 1994	EP				
SA	63 249837*	October 17, 1988	JP				

*Copy of Reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
SA	Ehrfeld et al., "Integrated Optics and Micro-Optics with Polymers," 1993, B.G. Teunber Verlag.*
SA	Brenner et al., "Deep Proton Irradiation of PMMA for a 3D Integration of Optical Components," pp. 159-176.* 1993
SA	Eguchi et al., "Gradient Index Polymer Optical Waveguide Patterned by Ultraviolet Irradiation," Japanese Journal of Applied Physics, vol. 28, no. 12, part 02, December 1, 1989, pp. L 2232-2235.*
SA	Lazare et al., "Microlenses Fabricated by Ultraviolet Excimer Laser Irradiation of Poly(Methyl Methacrylate) Followed by Styrene Diffusion," Applied Optics, vol. 35, no. 22, August 1, 1996, pp. 4471-4475.*

*Copy of Reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER	<i>Shamin Ahmed.</i>	DATE CONSIDERED	<i>7/24/01</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			